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Electronic Patent Application Submission

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FOR POROUS SURFACES
First Named Inventor: Zhonglin Wu
Domestic/Foreign Application: Domestic Application
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LEAKAGE FREE CERAMIC FILMS FOR POROUS SURFACES

First Named Inventor: Dr. Zhonglin Wu

SUBMITTED BY

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Marsteller/ Date Signed: 20030121

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Comments:



Electronic Information Disclosure Statement

LEAKAGE FREE CERAMIC FILMS FOR POROUS SURFACES

Application:



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Confirmation:

5119

Applicant(s):

Zhonglin Wu

Docket Number:

000115-210

Group Art Unit:

1741

Examiner:

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(5871624 or 5985113 or 6382958).pn.

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US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	5871624	1999-02-16		Crome	204	286.1
	P02	5985113	1999-11-16		Crome et al.	205	343
	P03	6382958	2002-05-07		Bool, III et al.	431	2

Signature

Examiner Name	Date

